

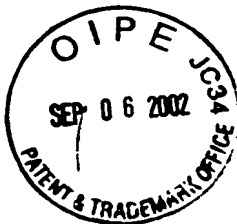
Docket No. 214019US-2

IN RE APPLICATION OF: EIJI SAKAGAMI

SERIAL NO: 09/955,076

FILED: SEPTEMBER 19, 2001

FOR: NONVOLATILE SEMICONDUCTOR MEMORY AND METHOD OF FABRICATING THE SAME



RECEIVED
SEP 19 2001
TECHNICAL CENTER 1280C

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Transmitted herewith is an amendment (w/ Marked-Up Copy) in the above-identified application.

- ☒ No additional fee is required
- ☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- ☒ Additional documents filed herewith: Marked-Up Copy, Letter Requesting Approval of Drawing Changes (marked in red) (4 Sheets)

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS	
TOTAL	21	MINUS	21	0	× \$18 =	\$0.00	
INDEPENDENT	4	MINUS	4	0	× \$84 =	\$0.00	
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			+ \$280 =	\$0.00	
		TOTAL OF ABOVE CALCULATIONS					\$0.00
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity					\$0.00
		<input type="checkbox"/> Recordation of Assignment			+ \$40 =	\$0.00	
		TOTAL					\$0.00

- ☐ A check in the amount of _____ is attached.
- ☒ Please charge any additional Fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- ☒ If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

OBLON, SPIVAK, McCLELLAND,
MAIER & MEUSTADT, P.C.

Gregory J. Maier
Registration No. 25,599

Eckhard H. Kuesters
Registration No. 28,870



22850

Tel. (703) 413-3000
Fax. (703) 413-2220
(OSMMN 10.00)

Docket No.: 214019US-2



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

RE APPLICATION OF:

EIJI SAKAGAMI

SERIAL NO: 09/955,076

FILED: SEPTEMBER 19, 2001

FOR: NONVOLATILE SEMICONDUCTOR MEMORY
AND METHOD OF FABRICATING THE SAME

:

: EXAMINER: HOWARD WEISS

:

: GROUP ART UNIT: 2814

RECEIVED
SEP - 9 2002
TECHNICAL UNIT 2802

LETTER REQUESTING APPROVAL OF DRAWING CHANGES

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Please review for approval the proposed changes to the Formal Drawings shown in **RED** on the attached photocopies of the drawings.

Once these changes have been reviewed and approved by the Examiner in charge of this case, instructions for their implementation will be forwarded to an approved bonded draftsman.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

Gregory J. Maier
Registration No: 25,599
Eckhard H. Kuesters
Registration No: 28,870



22850

(703) 413-3000
Fax No. (703) 413-2220
GJM:EHK:RAR:clh

7/ Letter to
Draftsman
9.16.02
C. Moore